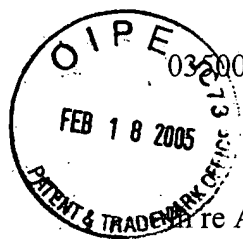


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03500.015729.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:

SHIN KITAMURA ET AL.

Application No.: 09/940,643

Filed: August 29, 2001

For: ELECTRON EMITTING DEVICE,
ELECTRON SOURCE, IMAGE-
FORMING APPARATUS, AND
METHOD FOR PRODUCING
ELECTRON-EMITTING DEVICE
AND ELECTRON-EMITTING
APPARATUS

U.S. Patent No. 6,848,962 B2

Issued: February 1, 2005

Examiner: Adolfo Nino

Group Art Unit: 2831

February 17, 2005

Commissioner for Patents
Mail Stop: PETITIONS
P.O. Box 1450
Alexandria, VA 22313-1450

COMMENTS ON DETERMINATION OF PATENT TERM ADJUSTMENT

Sir:

Patentees respectfully request review of the Patent Term Adjustment determined for the above-identified patent. The data presently available from the PAIR system appears to indicate an incorrect number of days determined for the USPTO Delay and/or for the Applicants' Delay.

Patentees' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,



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